



61 AF/3723

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4320**
Norio KIMURA et al. : Docket No. 2001_0122A
Serial No. 09/777,707 : Group Art Unit 3723
Filed February 7, 2001 : Examiner Maurina T. Rachuba
POLISHING APPARATUS

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TECHNOLOGY CENTER R3700

RESPONSE TO FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE AND PRECEDENCE IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

Sir:

In response to the Office Action dated April 28, 2004, having a three (3) month shortened-statutory period for response set to expire July 28, 2004, please amend the above-identified application as follows: